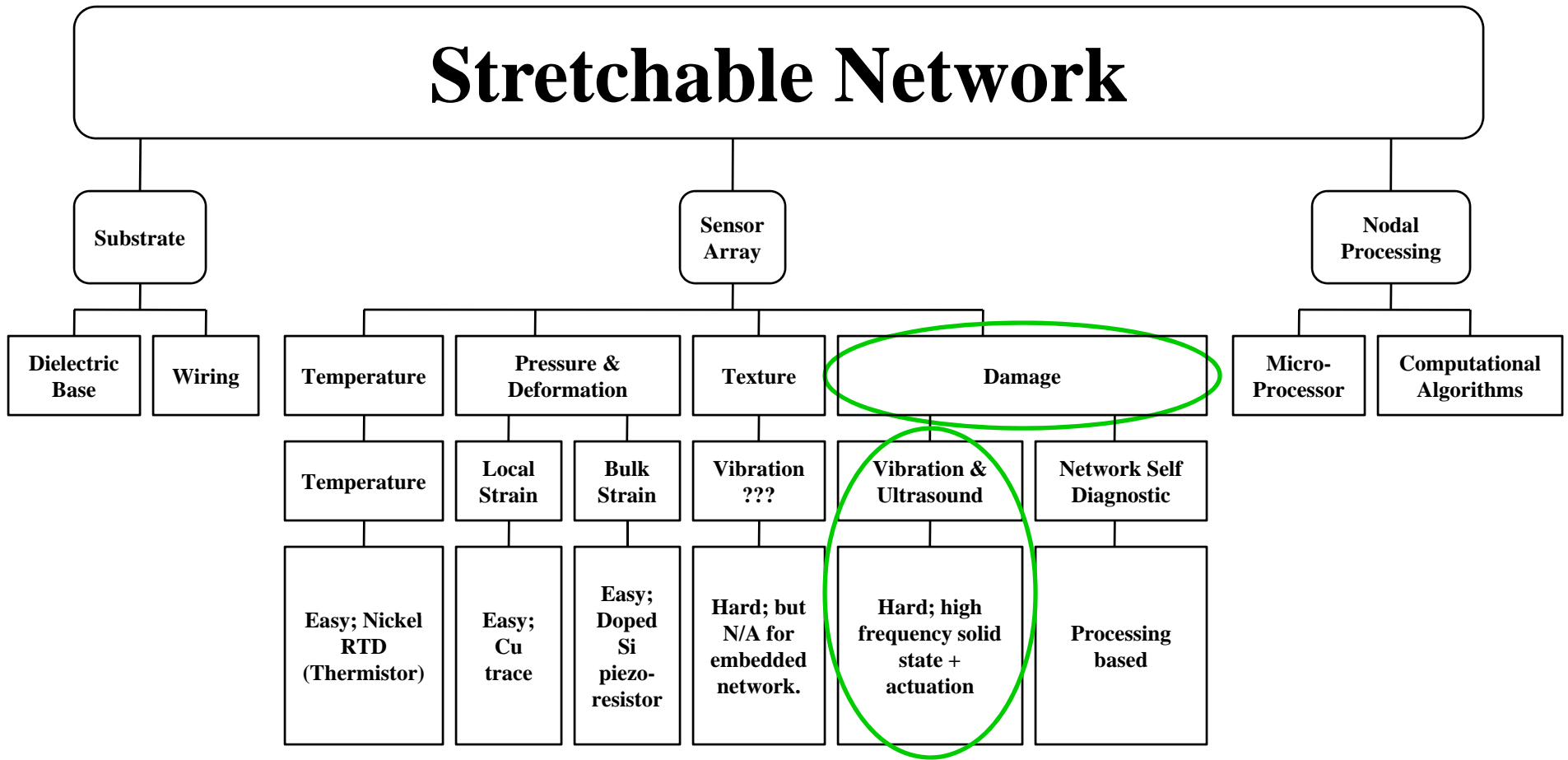




# Piezoelectric Devices for Stanford's Stretchable Network

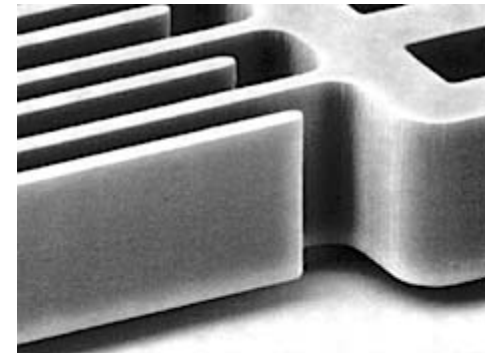
By: Nathan Salowitz

Advisor: Fu-Kuo Chang





- Micro Scale Devices
  - Sensing only, no actuation
  - Low Frequency
    - Typically  $<5\text{kHz}$
  - Require air gaps
    - Comb or tuning fork design
    - Not appropriate for immersion in a polymers or embedding in composites
- Macro-Scale Devices
  - Not easily scaled to appropriate size



Close up of a comb MEMS accelerometer, note air gaps

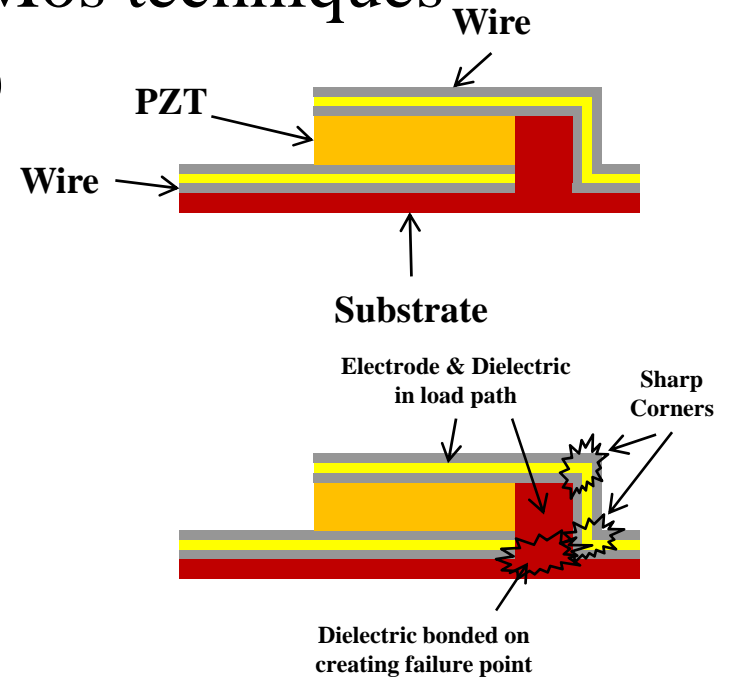


- Piezoelectric based systems provide the most capable SHM systems at the Macro scale
  - Ultrasonic systems capable of detecting multiple damage forms
  - Actuation & sensing capability
  - Impact and other forms of detection
  - Miniaturization will enable greater capability through more precise quantification of damage.

# Issues with “Traditional” PZTs



- Hard to manufacture using C-Mos techniques
  - Many layers(8 layers + 4 masks)
  - Application of individual PZTs
- Numerous failure points
  - Electrode may disbond
  - Wire breakage
    - Sharp corners
    - Wiring in load path
    - Possibility of numerous disbonds that could lead to breakage
- Indirect load path (through wiring and dielectric)





- Develop piezoelectric transducers that are easily manufacturable on a small scale.
  - Manufacturable in sizes from 200 $\mu\text{m}$  (7.9mil) to 800 $\mu\text{m}$  (31.5mil) in diameter
  - Manufacturable in C-Mos foundry/clean room, to enable concurrent manufacture of other components.
- Design should include
  - Clean load path to surrounding structure
  - Reduced stress concentration & failure points



- 2 pronged approach
  - Macro-scale (Easier to characterize and compare results to existing technology)
    - Utilize scalable manufacturing techniques easily adapted to micro-scale production
    - Develop techniques that will work at the micro scale
  - Micro-Scale
    - Develop manufacturing techniques to produce robust actuator/sensors at of the appropriate size
    - Develop functional and robust Piezoelectric actuator/sensors at appropriate scale



- Education
  - B.S. – Engineering Mechanics  
University of Wisconsin
  - M.S. – Aeronautics & Astronautics  
Stanford University
- Experience
  - Structural Analyst  
Boeing
- Hobbies
  - Sailing
  - Snowboarding



**SACL**

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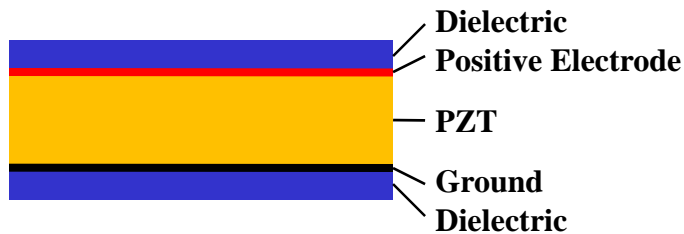


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## Traditional PZT



- Advantages
  - Standard polarization = easier bulk fabrication
- Disadvantages
  - Indirect load path
  - More layers
  - Significant step
    - Complicates nano-fabrication
    - Failure point

## Planar Electroded PZT



- Advantages
  - Fewer layers = easier nano-fabrication
  - Direct load path
  - Potential gain in actuation
    - $d_{33}$  direction
- Disadvantages
  - Non-standard polarization
  - Non-standard deformation